Configuration and Performance of a Local Electrode Atom Probe

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Two dedicated LEAP prototype instruments have recently been built and tested. Their design follows configurations proposed previously [1,2]. These instruments represent a significant departure from prior atom probe designs and so their key performance parameters are of interest.

These prototype LEAPs are ultrahigh vacuum (UHV) systems with a three stage vacuum system. This dry vacuum system uses titanium sublimation pumping with a large ion pump on the main chamber to achieve 3×10^{-9} Pa after a bake at 150°C. An intermediate chamber achieves 10^{-7} Pa with a magnetically-levitated turbopump. Eighteen specimens may be inserted at one time through the airlock and it takes less than ten minutes to complete insertion of a specimen into the main chamber. The specimen stage has 10 nm or smaller steps with 8 mm travel using an inchworm actuator on each of three axes. A vibration-isolated two stage helium refrigerator system cools the specimen to 27K or lower.

The configuration of the optics is shown in Fig. 1. The extraction field is independent of the final acceleration field. A fixed tip-to-detector distance of 40mm is used in the first prototype while a variable specimen-to-detector distance of 70 to 120 mm is used in the second prototype. The imaging detector uses a 40 mm diameter microchannel plate to achieve a large solid angle. With post acceleration of the ions, over 80° full angle for detection is achieved as demonstrated in Fig. 2. A crossed delay line anode is used for ion detection. This anode achieves better than 800x800 pixel resolution with a data rate capability of over 10^6 events per second.

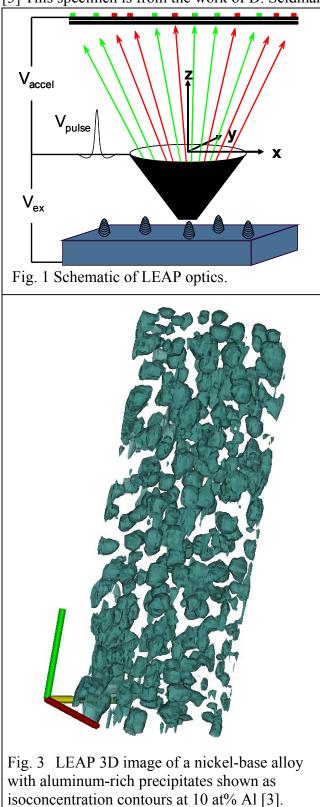
Because the extraction voltage in the local electrode configuration is significantly lower than in conventional atom probes, the pulse voltage is proportionally lower and this makes it possible to build much higher repetition rate pulsers. Imago's pulser routinely operates at 1×10^5 pulses per second. The electronics train needed to record data at this rate has also been developed. Sustained data collection rates of 1×10^6 atoms per minute with low errors are routinely utilized. An image recorded at this high data rate is shown in Fig. 3. This image of a model nickel-base alloy is approximately 87 nm diameter by 260 nm long and contains 55 million atoms [3]. There are over 300 precipitates of about 10 nm diameter in this image as shown by an isoconcentration contour for 10 atomic % Al.

A key element of the LEAP is the local extraction aperture. The size of the aperture opening influences the magnitude of the field enhancement and the ability to analyze microtips. To date, apertures as small as 20 micron diameter have been utilized to record images from both needles and microtips on planar surfaces.

Mass resolution of better than one part in 300 FWHM has been demonstrated on the first prototype LEAP. Fig. 4 shows a mass spectrum that demonstrates one part in 346 FWHM at W_{186}^{+3} (mass-to-charge ratio=62). Mass resolution of one part in 500 FWHM is expected in the second prototype LEAP at longer flight distances.

[1] T. F. Kelly et al., US patent #5,440,124 (1995).

[2] T. F. Kelly et al., Ultramicroscopy 62 (1996) 29-42.



[3] This specimen is from the work of D. Seidman of Northwestern University.

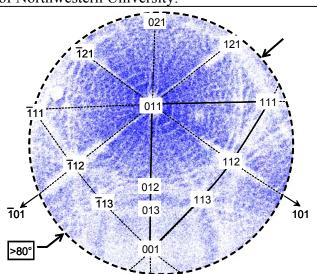


Fig. 2 Field evaporation image of tungsten with zone axes marked. This view is looking down the evaporation direction.

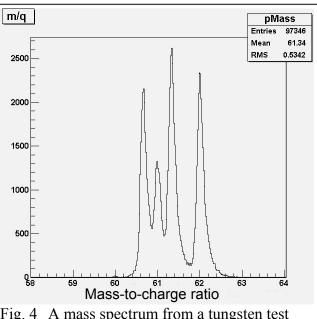


Fig. 4 A mass spectrum from a tungsten test specimen showing peaks of the triply ionized W (mass=182, 183, 184, and 186 amu). The FWHM mass resolution is measured as one part in 346 on the W_{186}^{+3} .